ch clean)	Dry		15min	-				i.				
Wet Bench: oxide etch + hydrophilic clean (RCA clean)	Risse		8 min					28				
	sC2		10 m va				Single Water Cleaning Tool Single Sten Clean	Step Cle	مرم	2000	}	*
	Rinse		%	} }	64 min Total -	Philic Clear		Rinse	20%			
	SC1		lomin					Oxide etch + hydrophilic clean	Chemica (30sec		- 2 min Total -
	 Risse	×	5				Single Wa-	Oxide et	Ris	20sec		
Figure 1 a	HF Etch	N 8 5				••	Figure 76	7	17+ E+CY	30 sec		<u> </u>

$$\frac{100^{-1} - CH_2}{(-):N - CH_2 - CH_2 - CH_2}$$

$$\frac{(-):N - CH_2 - CH_2 - N:(-)}{CH_2 - C-0:}$$

$$\frac{100^{-1} - CH_2}{00^{-1} - CH_2}$$

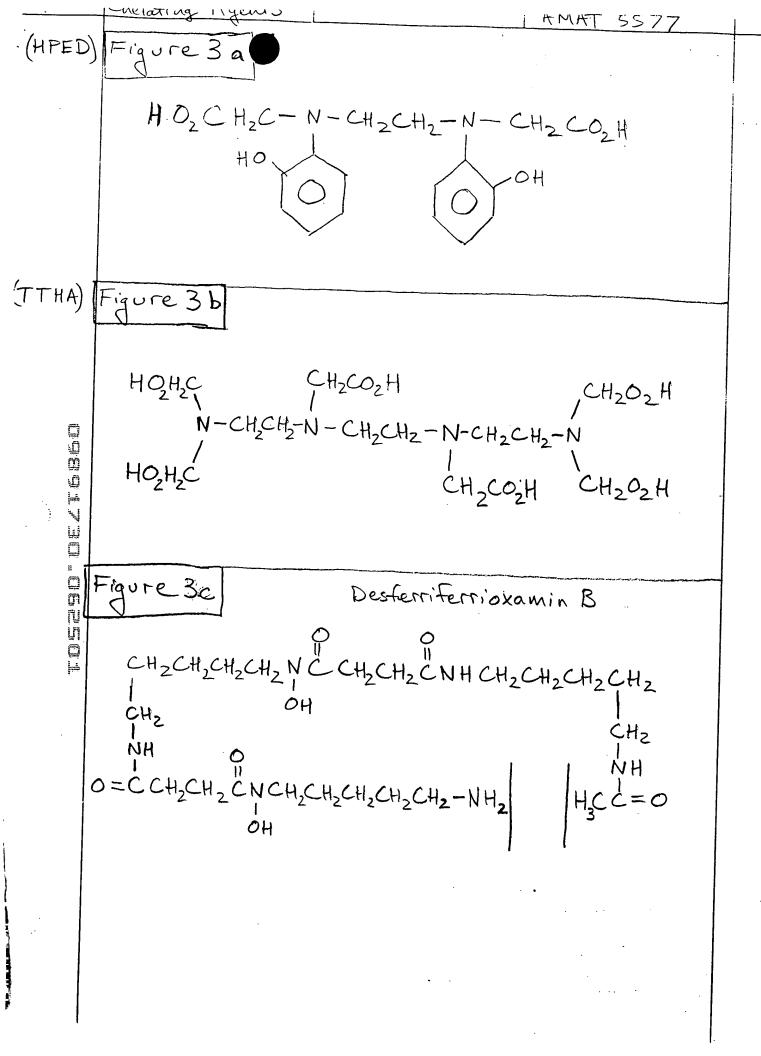
$$\frac{100^{-1} - CH_2}{00^{-1} - CH_2}$$

Binds Metal ions

Figure 26

$$M^{x+}$$
 $-0-C-CH_2$ $CH_2-C-0-M^{x+}$ M^{x+} $-N-CH_2-CH_2-N-M^{x+}$ $CH_2-C-0-M^{x+}$ $CH_2-C-0-M^{x+}$ $CH_2-C-0-M^{x+}$

FOSTAD OEZHODO



COSSIVE CHPLI

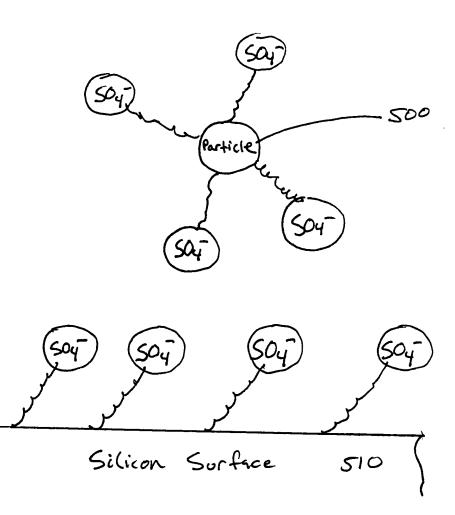


Figure 6a

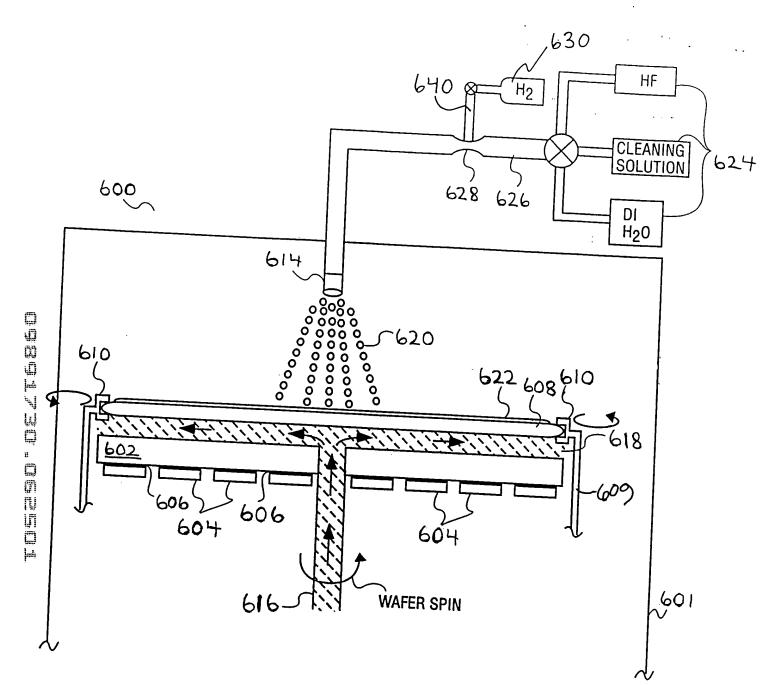
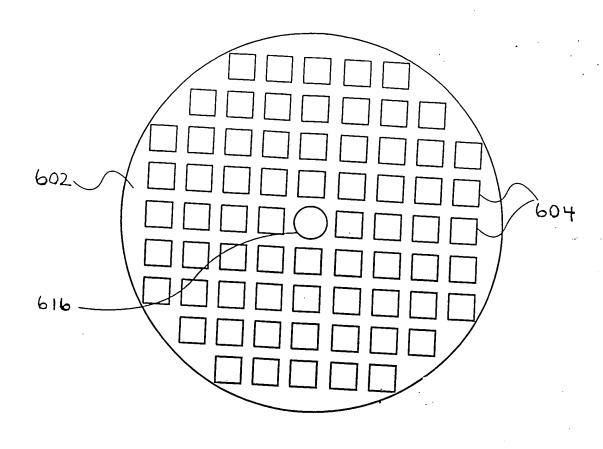


Figure 6b



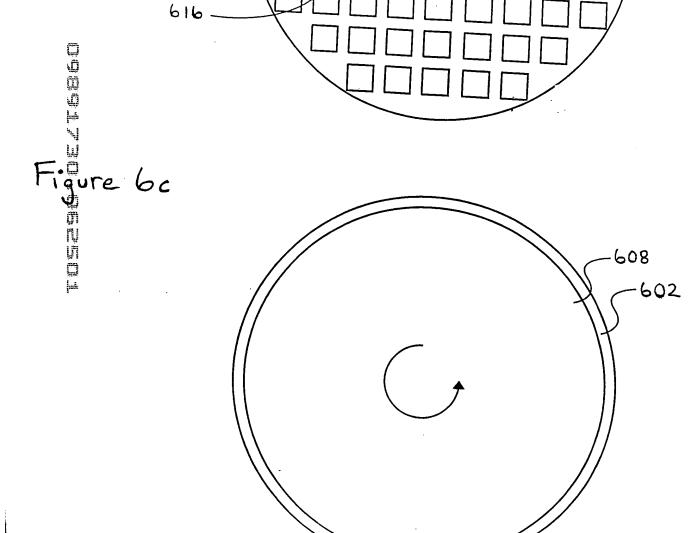
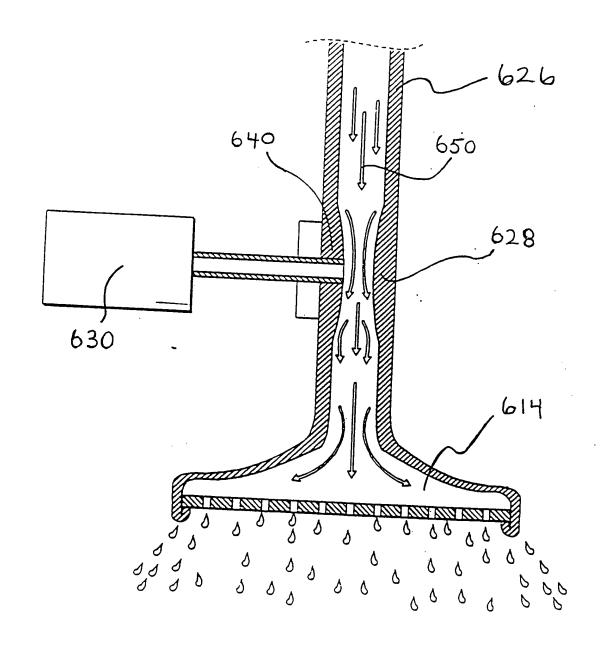
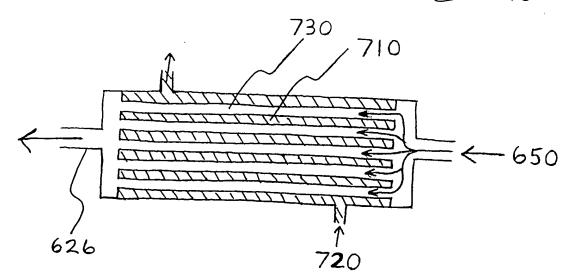


Figure 6d



TOTED. OEKLEDE



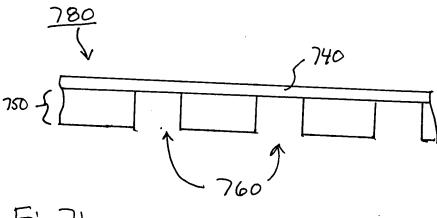
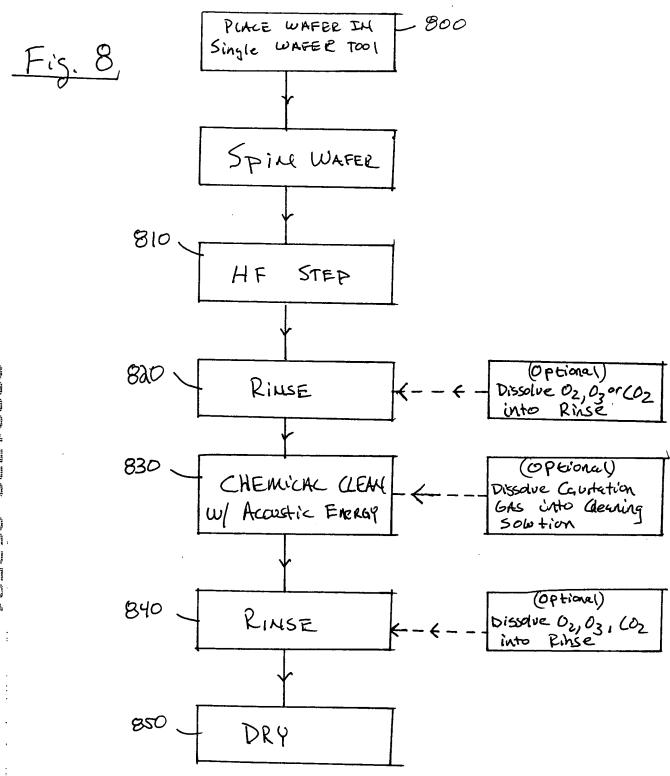


Fig.7b

COESIVED DESET



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